



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

: MAIL STOP: RCE

Akihisa HONGO et al.

: Docket No. 2001_0133A

Serial No. 09/762,582

: Group Art Unit 1753

Filed April 12, 2001

: Examiner Brian Mutschler

SUBSTRATE PLATING
METHOD AND APPARATUS

Confirmation No. 5731

PETITION FOR EXTENSION OF TIME

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

Petition hereby is made for a three month extension of time to respond to the communication of October 27, 2004.

The fee of \$1,020.00 is

submitted herewith.

to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.

Small entity status of this application is established by a Small Entity Status Assertion which

is enclosed.

has been previously submitted.

Respectfully submitted,

Akihisa HONGO et al.

By

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